Attorney's Docket 081468-0307473 Client Reference: P-1795.000-US





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 2813

VADIM YEVGENYEVICH BANINE ET AL.

Group Art Unit: 2851

Filed: December 31, 2003

Application No.: 10/748,851

Examiner: Della J. Rutledge

For: LITHOGRAPHIC APPARATUS HAVING A DEBRIS-MITIGATION SYSTEM, A SOURCE FOR PRODUCING EUV RADIATION HAVING A DEBRIS MITIGATION

SYSTEM AND A METHOD FOR MITIGATING DEBRIS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

EXTENSION OF TIME

The proceedings herein are for a patent application and the provisions of 37 C.F.R. 1.136 apply. Applicant petitions for a 3 months extension of time under 37 C.F.R. 1.136.

FEES

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been calculated as shown below:

	CLAIMS		JECT NO								
	REMAINING HIGHEST NO. AFTER PREVIOUSLY			PRESENT						ADDIT.	
	AMENDMENT	MENDMENT PAID FOR		EXTRA		RATE		<u>FEE</u>			
TOTAL	49	_	41	=	8	× \$	50.00	=	\$	400.00	
INDEP.	8	_	6	=	2	× \$	200.00	_=	\$	400.00	
FIRST PRESENTATION OF MULTIPLE DEP. +											
CLAIM						\$	360.00	=	\$	0.00	
TOTAL ADDITIONAL CLAIM FEE									\$	800.00	
EXTENSION OF TIME FEE									\$	1,020.00	
GRAND TOTAL									\$	1,820.00	

FEE PAYMENT

Authorization is hereby made to charge the amount of \$1,820.00 to Deposit Account No. 033975. Charge any additional fees required by this paper or credit any overpayment in the manner authorized above. A duplicate of this paper is attached.

Date: December 14, 2005

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SYSTEM AND A METHOD FOR MITIGATING DEBRIS

AMENDMENT

United States Patent and Trademark Office Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Office Action dated June 14, 2005, a response to which being due on December 14, 2005 with a three-month extension of time being filed herewith, please amend the above-identified application as follows:

12/15/2805 JADDO1 08800105 033975 19748851

01 FC:1201 408.00 DA 02 FC:1202 400.00 DA 03 FC:1253 1020.00 DA